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## PATENT APPLICATION

IN THE UNITED STATES PATEN	T AND TRADEMARK OFFICE
In re Application of:  KATSUMI NAKAGAWA, ET AL.  Application No.: 10/014,418  Filed: December 14, 2001  For: LIQUID PHASE GROWTH  PROCESS, LIQUID PHASE  GROWTH SYSTEM AND  SUBSTRATE MEMBER  PRODUCTION METHOD	Examiner: M. Song  Group Art Unit: 1765
Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	MENT
Sir:  In response to the Office Action the above-identified application as follows:	dated November 10, 2004, please amend
	I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on  February 10, 2005  (Date of Deposit)  Damond E. Vadnais, Reg. No. 52,310  (Name of Attorney for Applicant)  February 10, 2005  Signature  Date of Signature